



Mail Stop AF
PNET.009D

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Tsukasa Yajima

Serial No.: 09/768,271

Filed: January 25, 2001

For: SEMICONDUCTOR DEVICE HAVING PROTECTIVE LAYER ON FIELD OXIDE

#168 Just
3/16 M. Brown
5/16/03

Group Art Unit: 2814

Examiner: A. Mai

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: May 12, 2003
(Monday)

Pls. file 5/16/03
Sir: P.M.
In response to the Final Office Action dated January 10, 2003, the period for response having been extended one month to May 10, 2003, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

In the Drawings:

Please cancel Fig. 1(i). ✓

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In the Specification:

Replace the paragraph beginning on page 13, line 12 with the following paragraph:

"Thereafter, the side-wall 37 is formed by implementing the anisotropic etching